

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Li et al.

Applicant's Reference: LAM1P098 NOV 20 2000

Application No.: 09/222,588

Filed: December 28, 1998

Title: PERFORATED PLASMA CONFINEMENT
RING IN PLASMA REACTORS

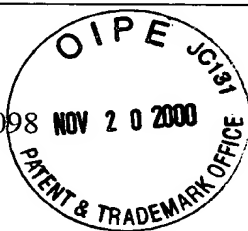
Examiner: Hassanzadeh, P.

Group: 1763

Issue Batch No: S90

Notice of Allowability Date:
September 27, 2000

#14 12/14



CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, DC 20231 on November 15, 2000.

Signed: _____

Agnes F. Spende

Separate Letter to the Official Draftsman

Assistant Commissioner for Patents
Box: Issue Fee
Washington, D.C. 20231

Dear Sir:

In response to the objections raised by the Draftsman in an action dated September 27, 2000 enclosed are the corrected formal drawings for the above-identified patent application. If the Draftsman has any question concerning the corrected drawings, he or she is respectfully requested to contact the undersigned.

Respectfully submitted,

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